

PATENT APPLICATION

Atty. Docket No.: 2522-033 Serial No. not yet assigned
Applicant: Eung-Joon LEE, In-Sun PARK and Ji-Soon PARK
Filing Date: July 29, 2003 Group: not yet assigned
For: METHOD FOR FORMING SILICIDE FILM OF A SEMICONDUCTOR DEVICE

**INFORMATION DISCLOSURE CITATION
FORM PTO-1449 (Modified)****U.S. PATENT DOCUMENTS**

Exam <u>Init</u>	<u>Ref</u>	Document <u>Number</u>	Issue <u>Date</u>	Name	Class	Sub Class
—	—	6,303,503B1	10/16/2001	Kamal et al.		

FOREIGN PATENT DOCUMENTS

Exam <u>Init</u>	<u>Ref</u>	Document <u>Number</u>	Publication <u>Date</u>	Country	Name
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OTHER DOCUMENTS

Exam <u>Init</u>	<u>Ref</u>	<u>Author, Title, Date, Pertinent Pages, Etc.)</u>
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Examiner: Asoke Kumar Sarkar

Date Considered: May 11, 2004